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Sutardja et al.

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(54) **METHODS OF MAKING PACKAGES USING THIN CU FOIL SUPPORTED BY CARRIER CU FOIL**

H01L 2224/32245 (2013.01); *H01L 2224/4809* (2013.01); *H01L 2224/48091* (2013.01); *H01L 2224/48247* (2013.01); *H01L 2224/73265* (2013.01); *H01L 2924/181* (2013.01); *Y10T 29/49146* (2015.01)

(71) Applicant: **Marvell World Trade Ltd., St. Michael (BB)**

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CPC *H05K 1/182*; *H05K 3/07*; *Y10T 29/49146*; *H01L 23/3107*; *H01L 21/4832*; *H01L 21/568*
USPC 174/260, 250, 251, 255, 257, 258
See application file for complete search history.

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(*) Notice: Subject to any disclaimer, the term of this patent is extended or adjusted under 35 U.S.C. 154(b) by 645 days.

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(21) Appl. No.: **13/962,731**

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(22) Filed: **Aug. 8, 2013**

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(65) **Prior Publication Data**

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Related U.S. Application Data

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(60) Provisional application No. 61/680,943, filed on Aug. 8, 2012, provisional application No. 61/680,932, filed on Aug. 8, 2012.

JP S59208756 11/1984

Primary Examiner — Tremesha S Willis

(51) **Int. Cl.**

H05K 1/16 (2006.01)
H05K 3/00 (2006.01)
H05K 1/18 (2006.01)
H01L 21/48 (2006.01)
H01L 21/56 (2006.01)
H01L 23/31 (2006.01)

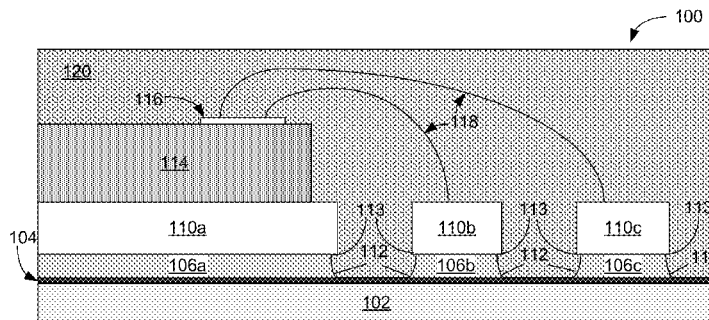
(57) **ABSTRACT**

In an embodiment, there is provided a method of creating a package, the method comprising: providing an initial substrate, wherein the initial substrate comprises a carrier foil, a functional copper foil, and an interface release layer between the carrier foil and the functional copper foil; building up copper portions on the functional copper foil; attaching a chip to a first copper portion; coupling the chip to a second copper portion; encapsulating at least the chip and the copper portions with a mold; and removing the carrier foil and interface release layer.

(52) **U.S. Cl.**

CPC **H05K 3/007** (2013.01); **H01L 21/4832** (2013.01); **H01L 21/568** (2013.01); **H05K 1/182** (2013.01); **H01L 23/3107** (2013.01);

19 Claims, 16 Drawing Sheets



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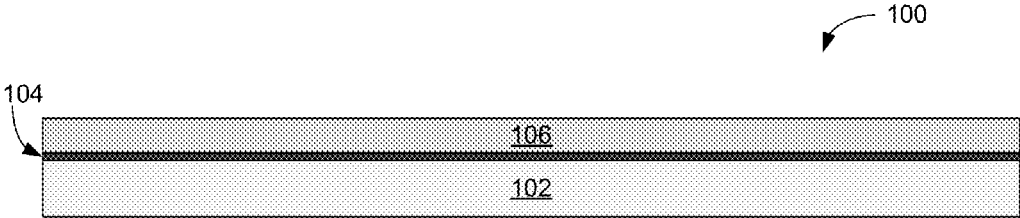


Fig. 1A

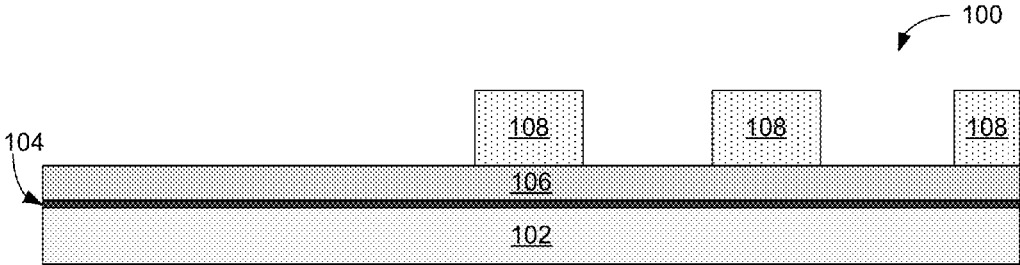


Fig. 1B

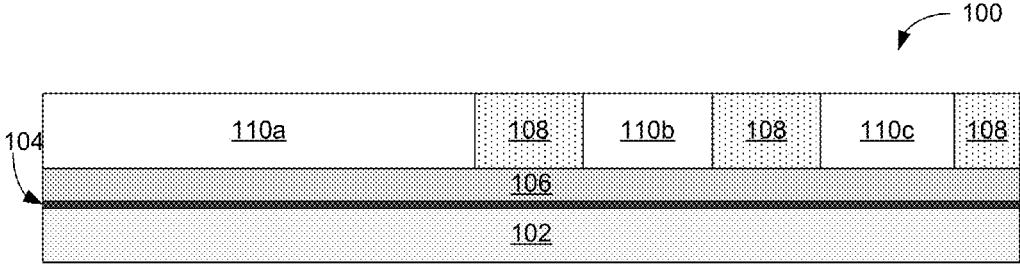


Fig. 1C

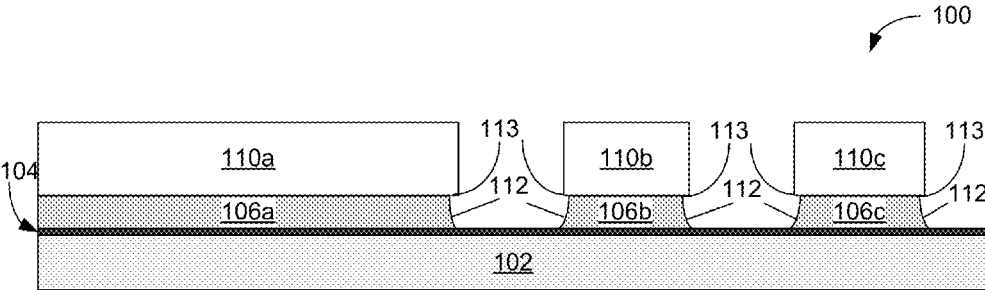


Fig. 1D

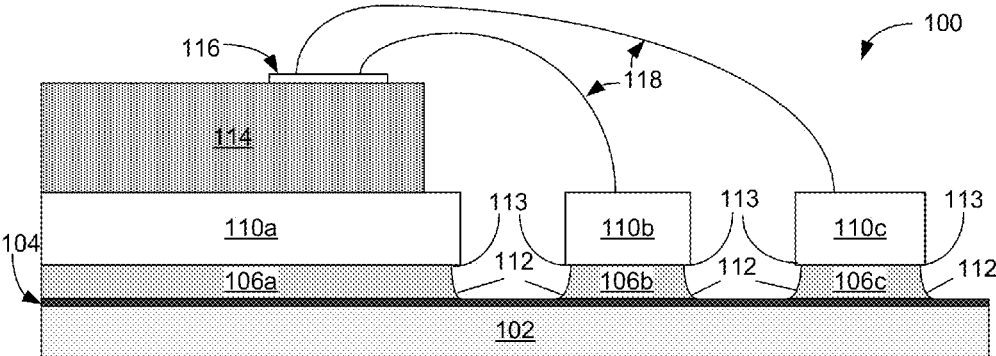


Fig. 1E

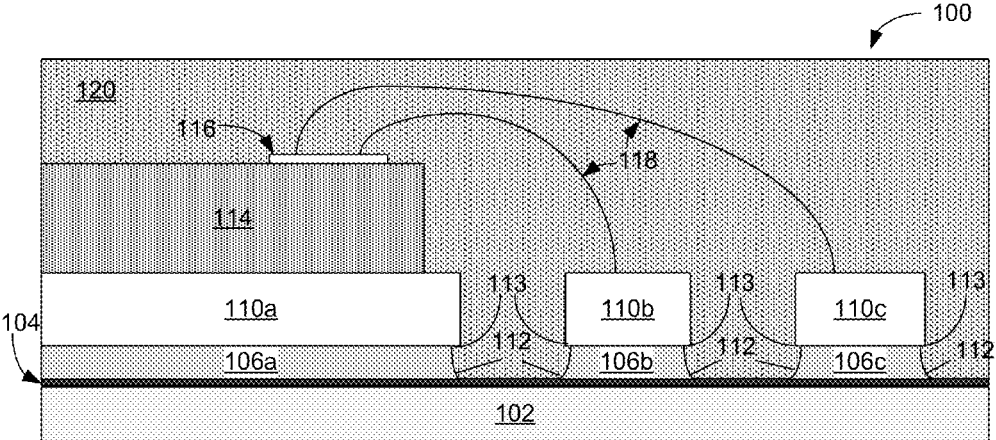


Fig. 1F

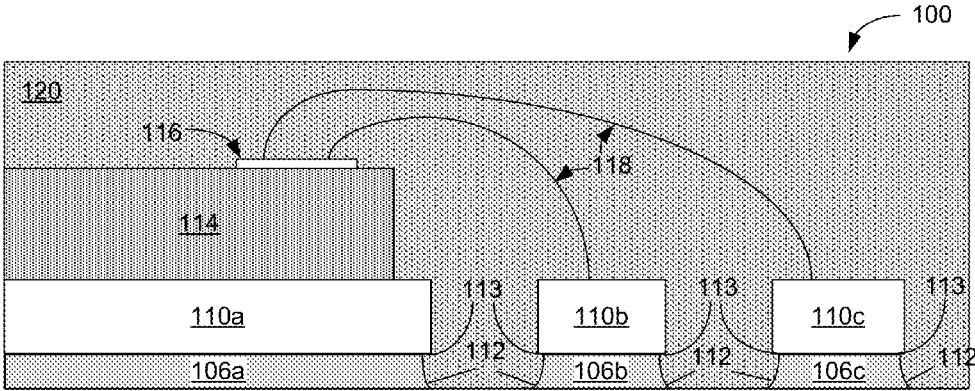


Fig. 1G

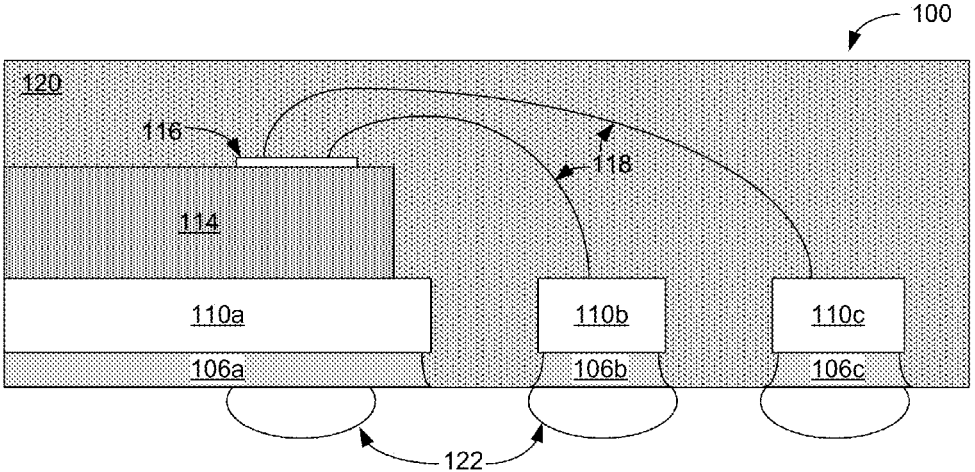


Fig. 1H

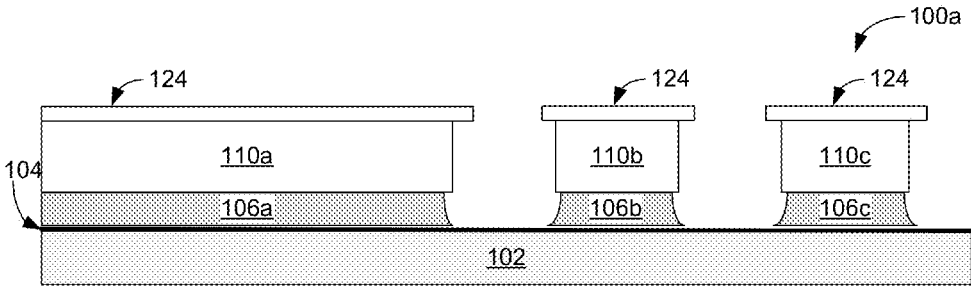


Fig. 1I

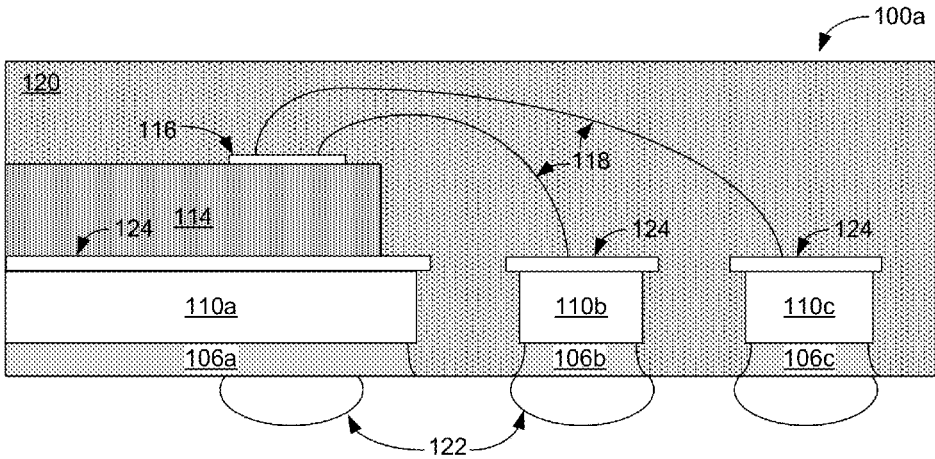


Fig. 1J

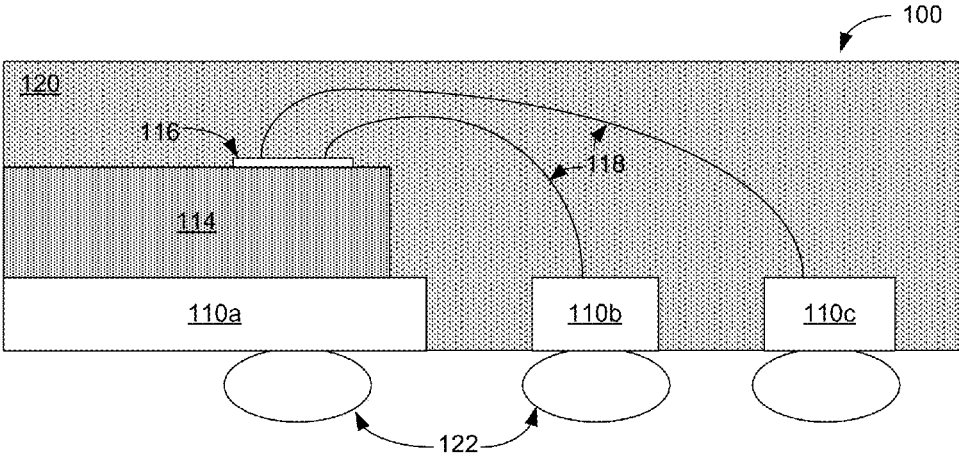


Fig. 1K

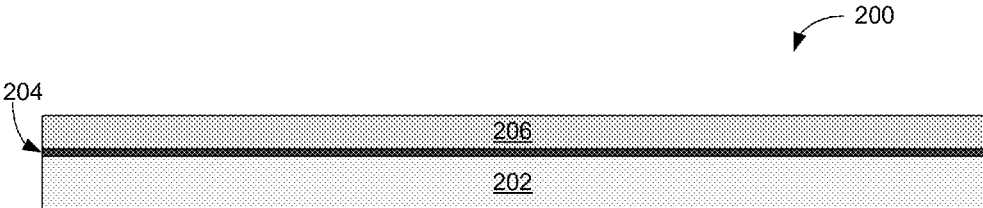


Fig. 2A

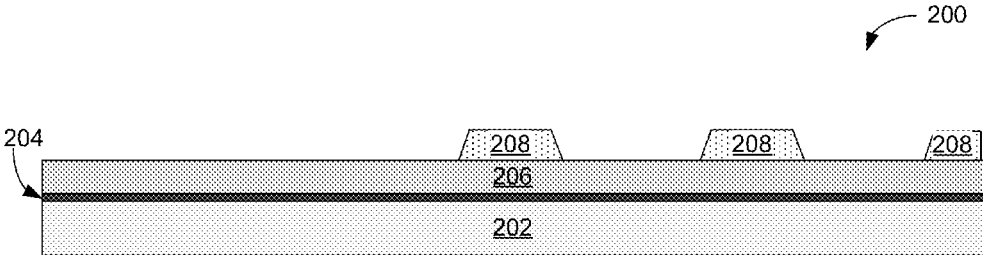


Fig. 2B

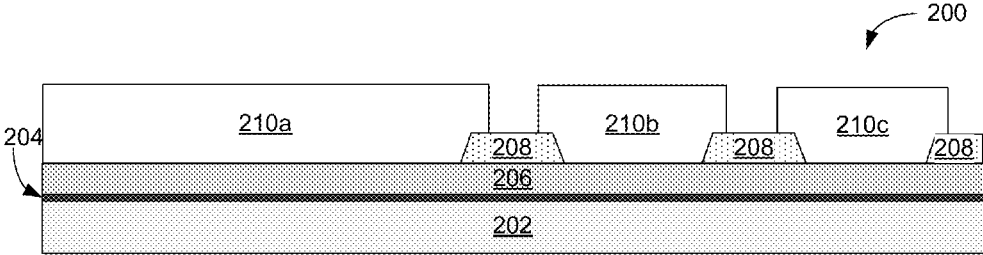


Fig. 2C

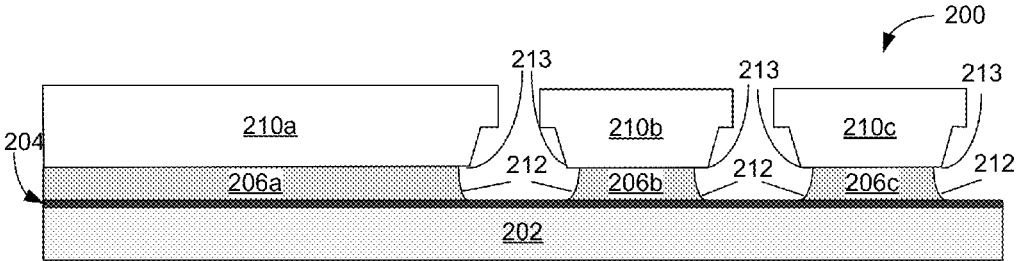


Fig. 2D

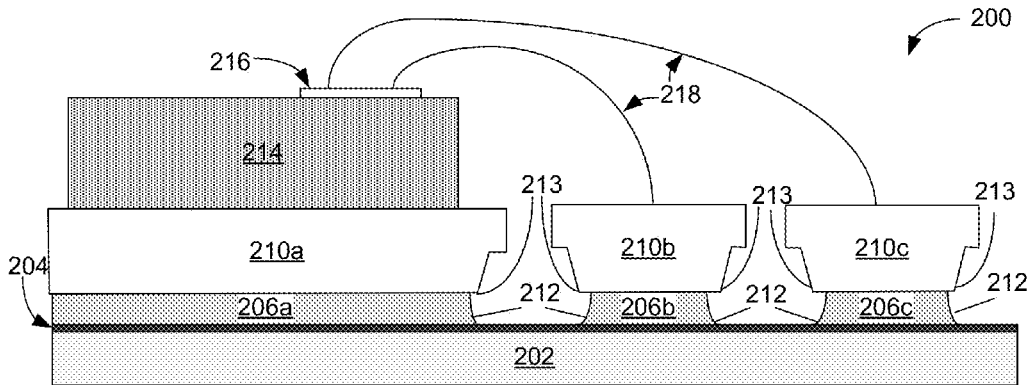


Fig. 2E

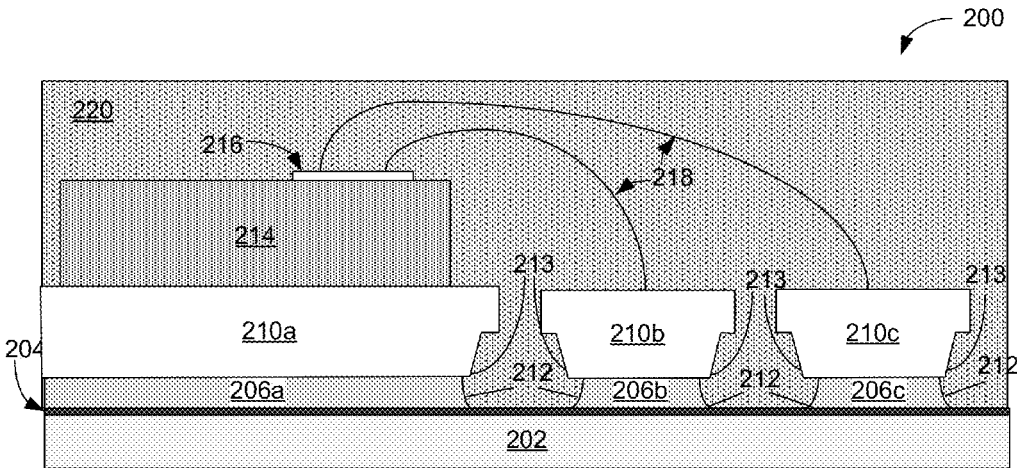


Fig. 2F

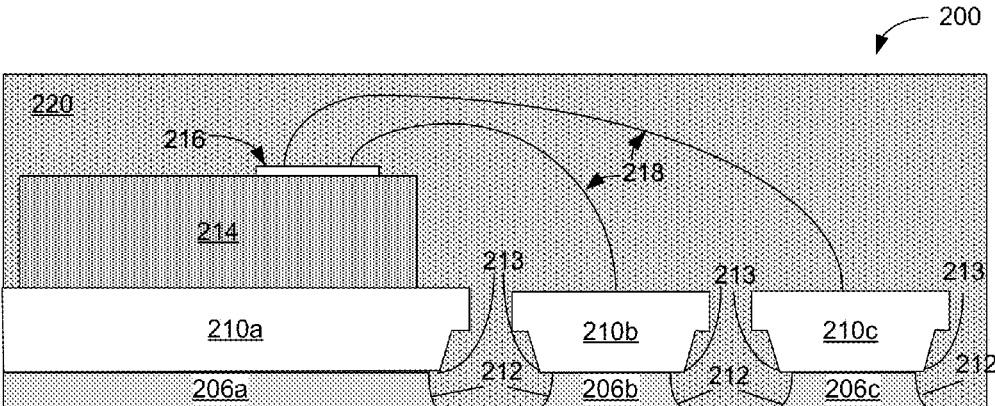


Fig. 2G

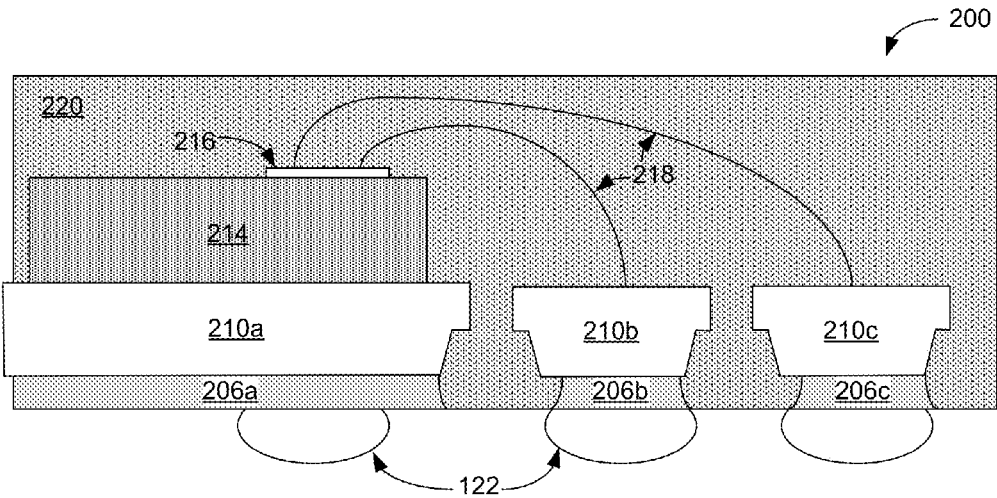


Fig. 2H

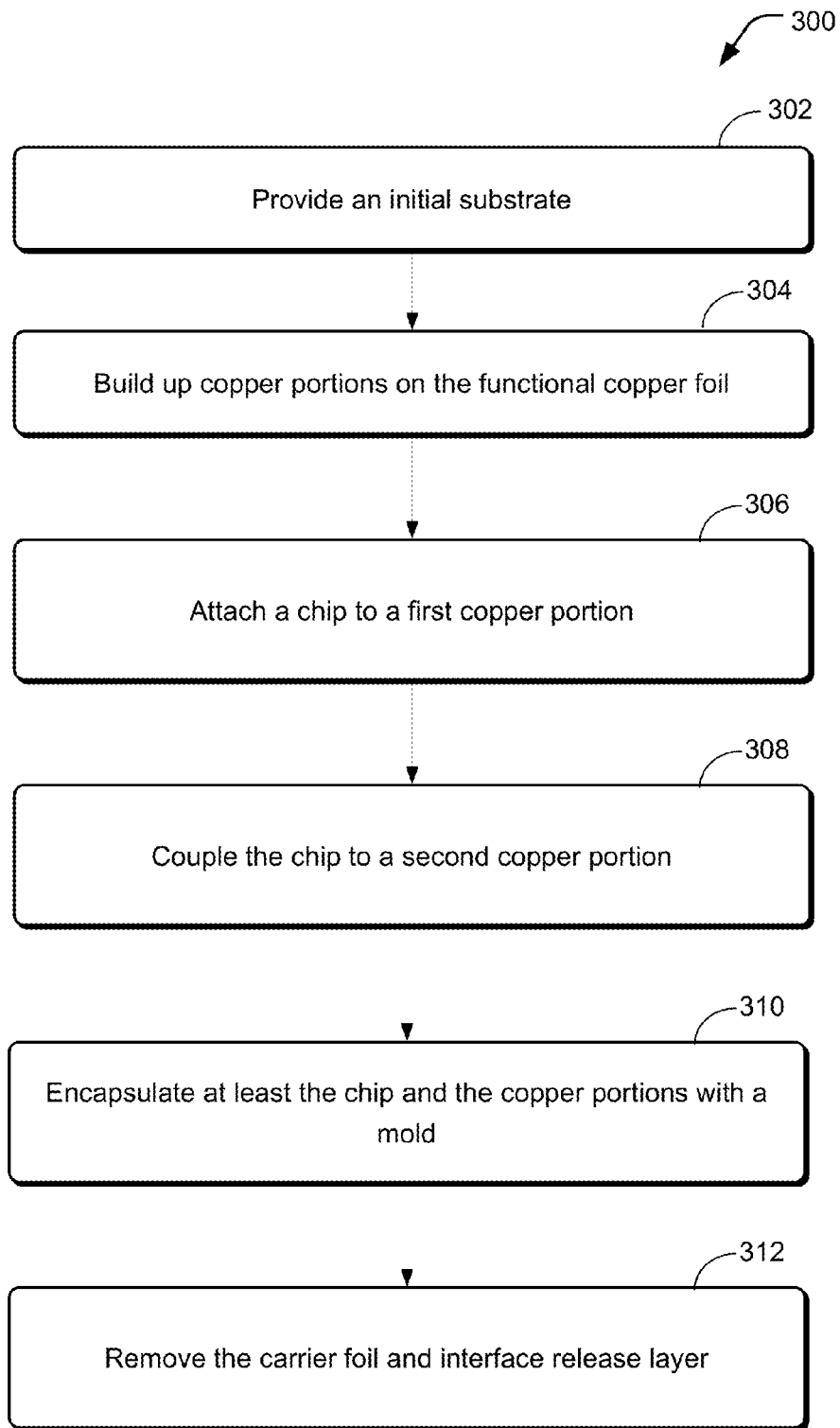


Fig. 3

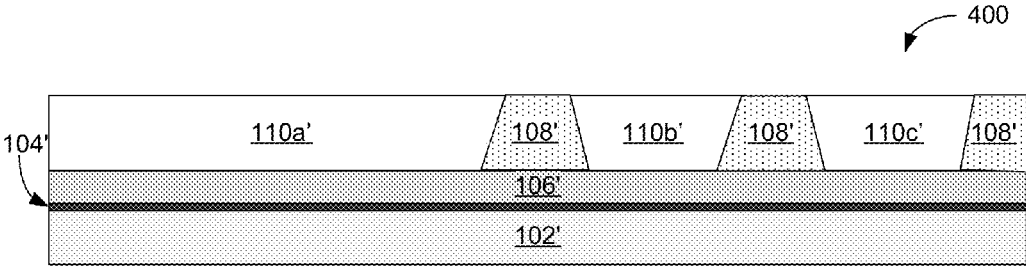


Fig. 4

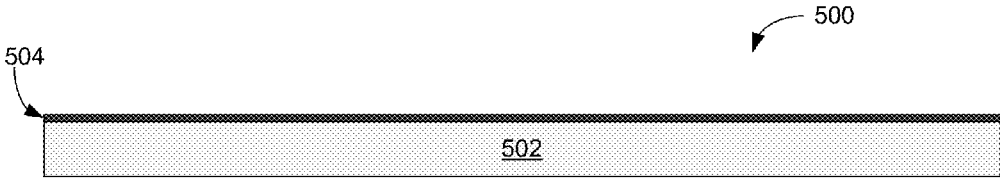


Fig. 5A

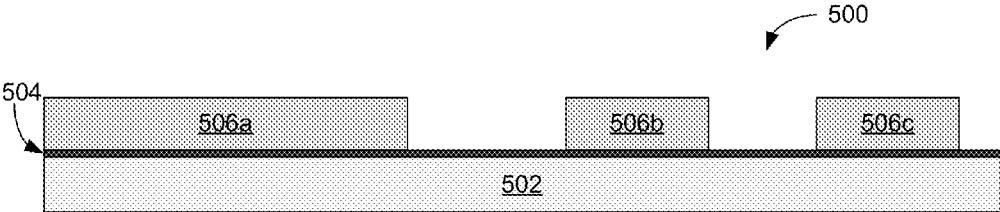


Fig. 5B

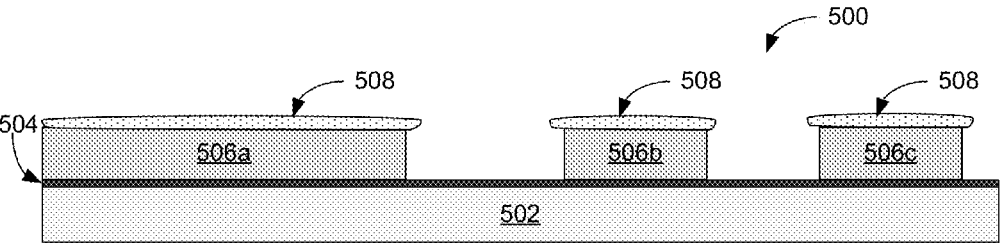


Fig. 5C

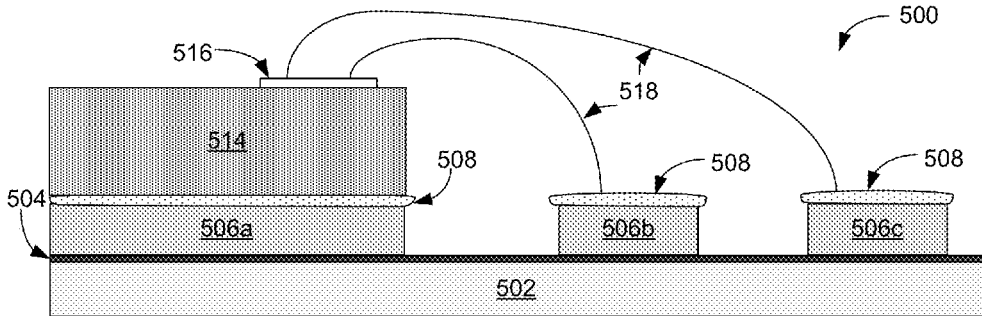


Fig. 5D

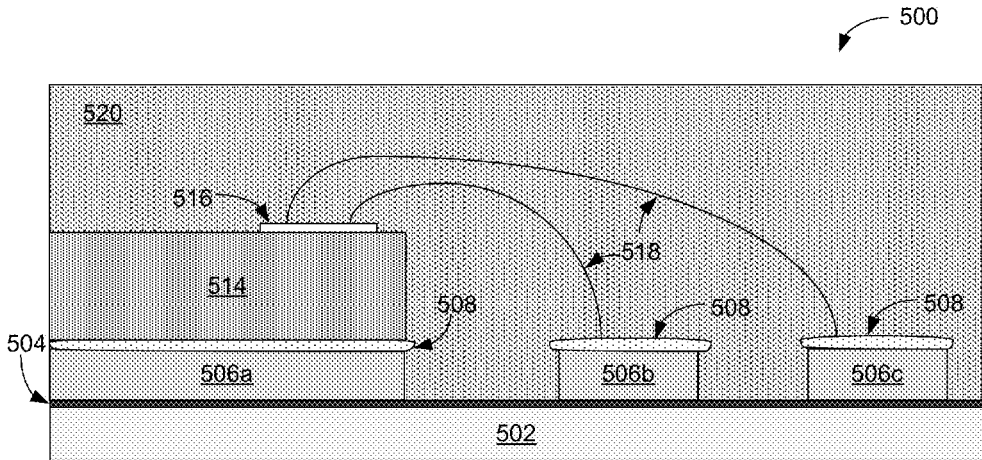


Fig. 5E

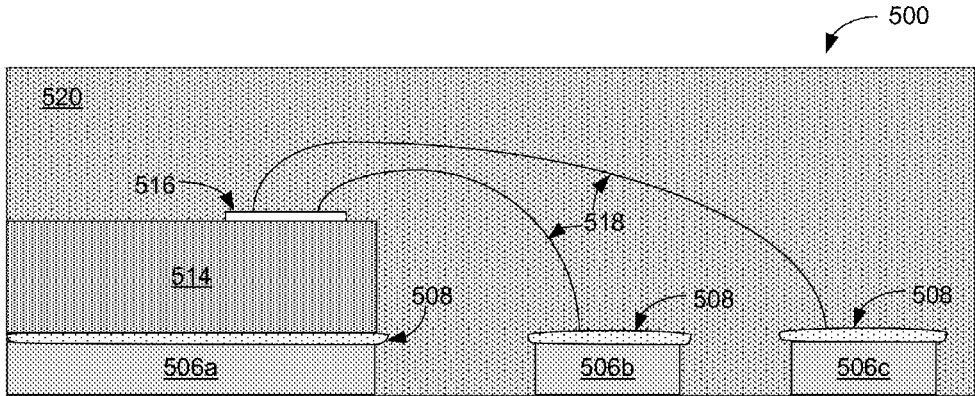


Fig. 5F

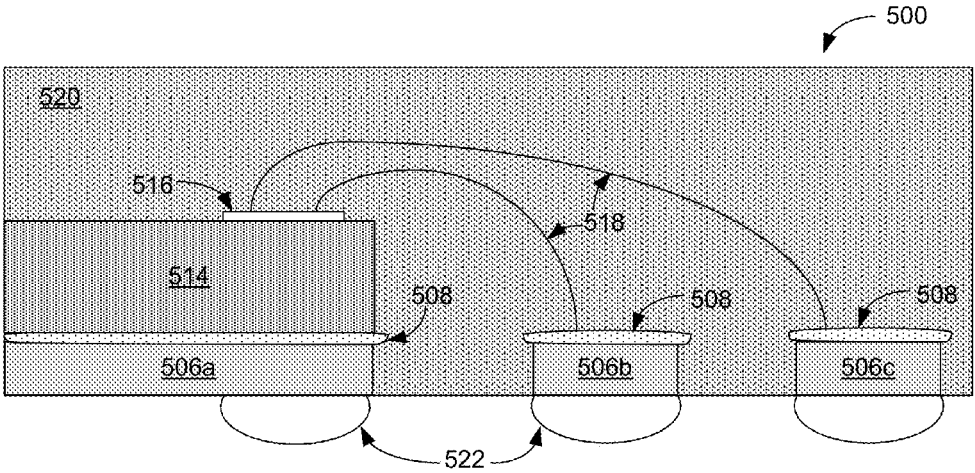


Fig. 5G

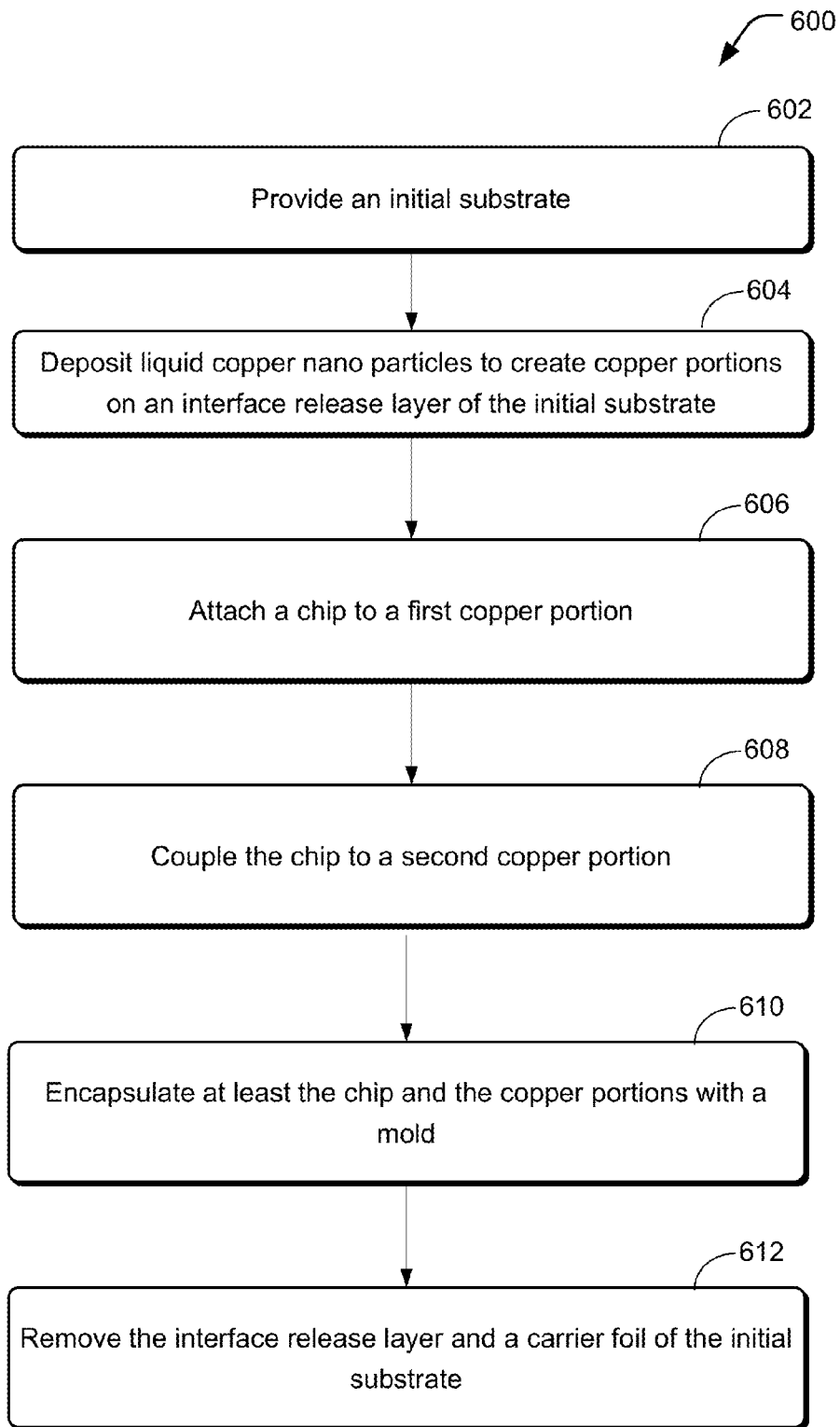


Fig. 6

METHODS OF MAKING PACKAGES USING THIN CU FOIL SUPPORTED BY CARRIER CU FOIL

CROSS-REFERENCES TO RELATED APPLICATIONS

The present disclosure claims priority to U.S. Provisional Patent Application No. 61/680,943, filed Aug. 8, 2012, and to U.S. Provisional Patent Application No. 61/680,932, filed Aug. 8, 2012, the disclosures of which are hereby incorporated by reference.

TECHNICAL FIELD

Embodiments of the present disclosure relate to the field of integrated circuits, and more particularly, to techniques, structures, and configurations for semiconductor chip packaging.

BACKGROUND

The background description provided herein is for the purpose of generally presenting the context of the disclosure. Work of the presently named inventor(s), to the extent the work is described in this background section, as well as aspects of the description that may not otherwise qualify as prior art at the time of filing, are neither expressly nor impliedly admitted as prior art against the present disclosure.

Microelectronic devices utilize packing arrangements that continue to become smaller and smaller. As such packaging arrangements become smaller, the stability and physical strength associated with such packages can become compromised. For example, creating packages with a peelable carrier foil that is removed upon completion of the package can leave the bottom of the package fairly flimsy. Thus, a mold can be provided that encompasses the package to thereby provide additional strength for the package. However, when the peelable carrier foil is removed upon completion of the package, various components may be pulled or “popped” out of the mold with the removal of the peelable carrier foil.

SUMMARY

In an embodiment, there is provided a method of creating a package, the method comprising: providing an initial substrate, wherein the initial substrate comprises a carrier foil, a functional copper foil, and an interface release layer between the carrier foil and the functional copper foil; building up copper portions on the functional copper foil; attaching a chip to a first copper portion; coupling the chip to a second copper portion; encapsulating at least the chip and the copper portions with a mold; and removing the carrier foil and interface release layer.

In an embodiment, there is provided a package comprising a functional copper foil; copper portions attached to the functional copper foil; a chip attached to a first copper portion, wherein the chip is coupled to a second copper portion; a mold encapsulating at least the chip and the copper portions, wherein portions of the functional copper foil between the copper portions are removed such that a bottom surface of each copper portion is exposed, and wherein the mold encapsulates the copper portions between the exposed bottom surfaces of the copper portions and the functional copper foil.

BRIEF DESCRIPTION OF THE DRAWINGS

Embodiments will be readily understood by the following detailed description in conjunction with the accompanying drawings. Embodiments are illustrated by way of example and not by way of limitation in the figures of the accompanying drawings.

FIGS. 1A-1H schematically illustrate various steps for creating a single layer package, in accordance with various embodiments.

FIGS. 1I-1K and 4 illustrate an additional step that can be performed to create another single layer package, in accordance with various embodiments.

FIGS. 2A-2H schematically illustrate various steps for creating another single layer package, in accordance with various embodiments.

FIG. 3 is a flow diagram that illustrates an example of a method for creating single layer packages, in accordance with various embodiments.

FIGS. 5A-5G schematically illustrate various steps for creating a single layer package, in accordance with various embodiments.

FIG. 6 is a flow diagram that illustrates an example of a method for creating single layer packages, in accordance with various embodiments.

DETAILED DESCRIPTION

FIGS. 1A-1H illustrate various steps for creating a single layer package **100** in accordance with various embodiments. With respect to FIG. 1A, an initial substrate is illustrated that utilizes a thin copper foil supported by a carrier foil during manufacture of the single-layer package. The initial substrate includes a carrier copper foil **102** that is peelable. The carrier copper foil **102** may be made of a different metal in other embodiments. An interface release layer **104** couples the carrier copper foil **102** to a thin functional copper foil **106**. The interface release layer **104** is generally made of chromium or a similar material. The interface release layer **104** prevents sticking of the thin functional copper foil **106** to the carrier copper foil **102**, which is peelable, and thus, allows for peeling and easier release of the copper carrier foil **102** from the thin functional copper foil **106**. Generally, the thin functional copper foil **106** has a thickness of just a few microns, while the carrier copper foil **102** has a thickness in the tens of microns.

FIG. 1B illustrates a photolithography step wherein a layer of photoresist (not illustrated) is developed, thereby resulting in a pattern of photoresist portions **108**. FIG. 1C illustrates a step of copper plating on the thin functional copper foil **106**, thereby resulting in copper portions **110a**, **110b**, **110c** located between the photoresist portions **108**. The arrangement of photoresist portions **108** and copper portions **110a**, **110b**, **110c** illustrated in FIGS. 1B and 1C is merely an example and is not meant to be limiting. More or fewer photoresist portions **108** and copper portions **110a**, **110b**, **110c** can be included if desired.

FIG. 1D illustrates a step of stripping and etching of the photoresist portions **108**, which results in the removal of the photoresist portions **108**. As can be seen, the stripping and etching results in grooves or valleys **112** located within the thin functional copper foil **106** below the plated copper portions **110a**, **110b**, **110c** such that portions of bottom surfaces **113** of the plated copper portions **110a**, **110b**, **110c**, are exposed over the grooves **112**. The stripping and etching process also creates portions **106a**, **106b**, **106c** from the thin

functional copper foil **106**. The interface release layer **104** helps provide an inherent etch stop mechanism to help prevent over etching.

FIG. 1E illustrates a step of attaching chip **114** to copper portion **110a**. The chip **114** can be attached to the copper portion **110a** via an appropriate epoxy or glue (not illustrated). Alternatively, the chip **114** can be attached to the copper portion **110a** via a flip chip attach process and, thus, would have direct electrical connection(s) with the copper portion **110a** via solder (not illustrated). The chip **114** includes a bond pad **116**. A wire bonding process results in wires **118** being routed from the bond pad **116** to the copper portions **110b**, **110c**.

FIG. 1F illustrates a molding step that results in a mold **120** that encapsulates and protects the package **100**. The mold **120** can be made of plastic or other suitable material. As can be seen, the mold **120** covers the chip **114** and bond pad **116**, as well as the wires **118**. The mold **120** also fills in along the sides of the various components and in between the copper portions **110a**, **110b**, **110c** and the portions of the thin functional copper foil **106a**, **106b**, **106c**.

FIG. 1G illustrates a step of removing the carrier copper foil **102** to complete the package **100**. Removal of the carrier copper foil **102** is facilitated by and results in the removal of the interface release layer **104**. Removal of the carrier copper foil **102** can be achieved by heating the package **100** at a medium temperature to release the interface release layer **104**. The carrier copper foil **102** can then be peeled away from the functional copper portions **106a**, **106b**, **106c** and the mold **120**.

As previously discussed, sometimes upon removal of the carrier copper foil from conventional packaging, various components similar to, for example, the copper portions **110b**, **110c** and the corresponding thin functional copper portions **106b**, **106c**, are pulled or “popped” out of the mold. However, in embodiments of the present disclosure, the exposed bottom surfaces **113** of the copper portions **110b**, **110c** that extend over the grooves **112** help inhibit removal or “popping” out of the copper portions **110b**, **110c** and the corresponding thin functional copper portions **106b**, **106c**. The copper portion **110a** also has an exposed bottom surface **113** that inhibits “popping” out of the copper portion **110a**.

With respect to FIG. 1H, solder balls **122** are attached to the thin functional copper portions **106a**, **106b**, **106c** to facilitate attachment of the resulting single-layer package **100** to a substrate such as, for example, a printed circuit board (PCB), another package, etc. (not illustrated). The solder balls **122** also provide direct electronic connections between the thin functional copper portions **106a**, **106b**, **106c** and the substrate (not illustrated).

FIG. 1I illustrates an optional step that can be performed after the copper plating step illustrated with respect to FIG. 1C. A hard metal layer stack may be performed to add metal portions **124** on the copper portions **110a**, **110b**, **110c**. However, in an embodiment, for example, such metal portions **124** are optional, and are absent on one or more of the copper portions **110a**, **110b**, **110c** (e.g., absent on the copper portion **110a**, although not illustrated in FIG. 1I). These hard metal portions **124** can be etched in order to provide the elongated shape illustrated in FIG. 1I. As can be seen, the hard metal portions **124** are wider than the copper portions **110a**, **110b**, **110c**. The remaining steps described with respect to FIGS. 1D-1H are then performed. This results in a package **100a** illustrated in FIG. 1J. The hard metal layer portions **124** provide further mechanical assistance in preventing the copper portions **110a**, **110b**, **110c** and corresponding thin functional copper portions **106a**, **106b**, **106c**

from popping out during removal of the peelable carrier copper foil **102**, as described with respect to FIG. 1G.

FIGS. 1B-1C illustrate a rectangular shape for the photoresist portions **108**, and FIGS. 1B-1J illustrate the walls of the copper portions **110a**, **110b**, **110c** to be perpendicular to the carrier copper foil **102**. However, in other embodiments, the photoresist portions **108** can have any other appropriate shape, and accordingly, the walls of the copper portions **110a**, **110b**, **110c** may not be perpendicular to the carrier copper foil **102**. For example, FIG. 4 illustrates an embodiment in which photoresist portions **108'** (which may be, other than the shape, similar to the photoresist portions **108** of FIG. 1C) may have trapezoidal shapes. FIG. 4 is similar to FIG. 1C, except for the difference in the shapes of various components in these two figures. In FIG. 4, as walls of the photoresist portions **108'** are not perpendicular to the carrier copper foil **106'**, walls of copper portions **110a'**, **110b'**, **110c'** are also not perpendicular to the carrier copper foil **106'**. The remaining steps described with respect to FIGS. 1D-1J are then performed on the package **100'** of FIG. 4.

In FIGS. 1A-1J, the carrier copper foil **102** acts as a carrier layer and comprises copper, and the thin functional copper foil **106** comprises copper. In another embodiment, the thin functional copper foil **106** is replaced by, for example, thin aluminum foil (e.g., the foil **106** becomes a thin aluminum layer). In such an embodiment, portions of the aluminum layer **106** can be oxidized (e.g., using anodization) to form aluminum oxide. For example, referring to FIG. 1B, portions of the aluminum layer **106** underneath the photoresist portions **108** are preserved, while the remaining portions of the aluminum layer **106** that are not covered by any photoresist portions **108** are oxidized to form aluminum oxide portions. Consequently, a preserved portion of the aluminum layer **106** is sandwiched between aluminum oxide portions. The aluminum oxide portions then create a natural mask for subsequent copper plating (although, in an embodiment, the aluminum layer is prepared before such oxidation and/or copper plating). The photoresist portions **108** are then removed and copper portions **110** are then deposited in the space previously occupied by the photoresist portions **108**. A copper portion **110** is thus isolated by the aluminum oxide portions. It should be noted that in the embodiment where the aluminum layer is used in lieu of the thin functional copper foil, the photoresist portions are used to create space for the copper portions. Thus, these photoresist portions may be larger than the photoresist portions used in connection with the process described in FIG. 1B. In such an embodiment, once the package is assembled (e.g., subsequent to depositing the mold **120** in FIG. 1F), the carrier copper foil **102** is removed (e.g., similar to FIG. 1G). The left over aluminum layer **106** (e.g., illustrated as layers **106a**, **106b**, **106c** in FIGS. 1G and 1H) under the copper portions **110a**, **110b**, **110c** are then etched away by chemical reaction, leaving a bottom surface of the copper portions **110a**, **110b**, **110c** exposed. For example, as illustrated in FIG. 1K, the carrier copper foil **102** and the layers **106a**, **106b**, **106c** are removed, leaving the bottom surface of the copper portions **110a**, **110b**, **110c** exposed. Then solder balls **122** are attached to the exposed bottom surface of the copper portions **110a**, **110b**, **110c**, as illustrated in FIG. 1K. In another embodiment, instead of attaching solder balls **122** to the exposed bottom surface of the copper portions **110a**, **110b**, **110c**, a thin layer of solder is applied to the exposed bottom surface of the copper portions **110a**, **110b**, **110c**.

In the embodiment of FIGS. 1A-1K, the carrier copper foil **102** comprises copper. However, in another embodiment, the carrier copper foil **102** is replaced by a carrier

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aluminum foil (i.e., aluminum is used instead of copper to form the carrier foil **102**), which may, for example, lead to lowering the cost of the semiconductor package. In such an embodiment, the thin functional copper foil **106** is not used; instead, a single aluminum layer or carrier aluminum foil is used. Similarly, aluminum oxide portions are created using the aluminum layer to provide isolation between copper portions. An appropriate interface release layer **104** is used between the carrier aluminum/aluminum layer and the copper portions in order to promote peeling/separation.

FIGS. 2A-2H illustrate various steps for creating another embodiment of a single-layer package **200** using a thin copper foil supported by a carrier foil during manufacturing. With respect to FIG. 2A, an initial substrate includes a carrier copper foil **202**, which is peelable, coupled via an interface release layer **204** to a thin functional copper foil **206**. The carrier copper foil can be some other type of metal. The interface release layer **204** generally includes chromium or a similar material.

FIG. 2B illustrates a photolithography step wherein a layer of photoresist (not illustrated) is deposited and developed, thereby resulting in photoresist portions **208**. FIG. 2C illustrates a step of copper plating on the thin functional copper foil **206**, thereby resulting in copper portions **210a**, **210b**, **210c** located between the photoresist portions **208**. In an embodiment, at least portions of copper portions **210a**, **210b**, **210c** are over at least portions of the photoresist portions **208**, as illustrated in FIG. 2C. The arrangement of photoresist portions **208** and copper portions **210a**, **210b**, **210c** illustrated in FIGS. 2B and 2C is merely an example and is not meant to be limiting. More or fewer photoresist portions **208** and copper portions **210a**, **210b**, **210c** can be included if desired.

FIG. 2D illustrates a step of photoresist stripping and etching, which results in removal of the photoresist portions **208**. As can be seen, the copper portions **210a**, **210b**, **210c** generally have a mushroom shape upon completion. Thus, the top portion of the copper portions **210a**, **210b**, **210c** is wider than the bottom portion to create a plug-like feature. As can be seen, the stripping and etching results in grooves or valleys **212** located within the thin functional copper foil **206** below the copper portions **210a**, **210b**, **210c** such that portions of the bottom surfaces **213** of the copper portions **210a**, **210b**, **210c**, are exposed over the grooves **212**. The interface release layer **204** helps provide an inherent etch stop mechanism to help prevent over etching.

FIG. 2E illustrates a step of attaching a chip **214** to copper portion **210a**. The chip **214** can be attached to the copper portion **210a** via an appropriate epoxy or glue (not illustrated). Alternatively, the chip **214** can be attached to the copper portion **210a** via a flip chip attach process and thus, would have direct electrical connection(s) with the copper portion **210a** via solder (not illustrated). The chip **214** includes a bond pad **216**. A wire bonding process results in wires **218** being routed from the bond pad **216** to the copper portions **210b**, **210c**.

FIG. 2F illustrates a molding operation that provides a mold **220** that encapsulates and protects the package **200**. The mold **220** can be made of plastic or other suitable material. As can be seen, the mold **220** covers the chip **214** and bond pad **216**, as well as the wires **218**. The mold **220** also fills in along the sides of the various components and in between the copper portions **210a**, **210b**, **210c** and the portions of the thin functional copper foil **206a**, **206b**, **206c**.

FIG. 2G illustrates a step of removing the carrier copper foil **202** to complete the package **200**. Removal of the carrier copper foil **202** is facilitated by and results in the removal of

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the interface release layer **204**. Removal of the carrier copper foil **102** can be achieved by heating the package **100** at a medium temperature to release the interface release layer **104**. The carrier copper foil **102** can then be peeled away from the functional copper portions **106a**, **106b**, **106c** and the mold **120**.

As previously discussed, sometimes upon removal of the carrier copper foil from conventional packaging, various components that are similar to, for example, the copper portions **210b**, **210c** and the corresponding thin functional copper portions **206b**, **206c**, are pulled or “pop” out of the mold. However, in embodiments of the present disclosure, the exposed bottom surfaces **213** of the copper portions **210b**, **210c** that extend over the grooves **212** help inhibit removal or “popping” out of the copper portions **210b**, **210c** and the corresponding thin functional copper portions **206b**, **206c**. Additionally, the mushroom shape of the copper portions **210b**, **210c** results in the plug-like feature of the copper portions **210b**, **210c** that provides additional mechanical resistance to “popping” out of the copper portions **210b**, **210c** since the top portions of the copper portions **210b**, **210c** are wider than the bottom portions. The copper portion **210a** also has a substantially mushroom shape on at least one side and an exposed bottom surface **213** that inhibits “popping” out of the copper portion **210a**.

With respect to FIG. 2H, solder balls **222** are attached to the thin functional copper portions **206a**, **206b**, **206c** to facilitate attachment of the resulting single-layer package **200** to a substrate such as, for example, a printed circuit board (PCB), another package, etc. (not illustrated). The solder balls **222** also provide direct electronic connections between the thin functional copper portions **206a**, **206b**, **206c** and the substrate (not illustrated).

The packages **100**, **100a** and **200** are generally single layer ball grid array (BGA) packages. The packages **100**, **100a** and **200** are also referred to as quad-flat no-leads (QFN) packages.

FIG. 3 illustrates an example of a method **300** for creating a package, such as, for example, packages **100**, **100a** and **200**. At **302**, an initial substrate is provided. The initial substrate comprises a carrier foil, a functional copper foil and an interface release layer between the carrier foil and the functional copper foil. At **304**, copper portions are built up on the functional copper foil. At **306**, a chip is attached to a first copper portion. At **308**, the chip is coupled to a second copper portion. At **310**, at least the chip and the copper portions are encapsulated with a mold. At **312**, the carrier foil and interface release layer are removed.

FIGS. 5A-5G illustrate various steps for creating a single layer package **500** in accordance with various embodiments. With respect to FIG. 5A, an initial substrate is illustrated that utilizes a carrier foil during manufacture of the single-layer package **500**. The initial substrate includes a carrier copper foil **502** that is peelable. The carrier copper foil **502** may comprise a different metal if desired. An interface release layer **504** is coupled to the carrier copper foil **502** and generally includes chromium or a similar material. The interface release layer **504** prevents sticking of the carrier copper foil **502** to other components (not illustrated in FIG. 5A) of the package **500**. More particularly, the interface layer **504** allows for peeling and easier release of the copper carrier foil **502** from the package **500** upon completion of the package **500**, as will be further described herein. Generally, the carrier copper foil **502** has a thickness in the tens of microns.

FIG. 5B illustrates a step of providing copper portions **506a**, **506b**, **506c** on the carrier copper foil **502**. The copper

portions **506a**, **506b**, **506c** are provided by depositing liquid copper nano particles onto the interface release layer **504** in a desired pattern for the package **500**, similar to a printing operation. The copper portions **506a**, **506b**, **506c** are then cured or dried in order to solidify the copper portions **506a**, **506b**, **506c**. The arrangement of copper portions **506a**, **506b**, **506c** illustrated in FIG. 5B is merely an example and is not meant to be limiting. More or fewer copper portions **506a**, **506b**, **506c** can be included if desired depending upon the design of the package **500**.

FIG. 5C illustrates an optional step of providing a conductive top **508** on each copper portion **506a**, **506b**, **506c**. The conductive tops **508** can be provided by a dendrite formation of portions of a conductive material such as for example, copper, gold, silver, etc. Thus, the conductive tops **508** are generally grown on the copper portions **506a**, **506b**, **506c**. As can be seen, the conductive tops **508** are wider than the copper portions **506a**, **506b**, **506c**. The conductive tops **508** provide mechanical assistance in preventing the copper portions **506a**, **506b**, **506c** from popping out during removal of the peelable carrier copper foil **502**, as will be described herein.

FIG. 5D illustrates a step of attaching a chip **514** to copper portion **506a**. The chip **514** can be attached to the copper portion **506a** via an appropriate epoxy or glue (not illustrated). Alternatively, the chip **514** can be attached to the copper portion **506a** via a flip chip attach process and thus, would have direct electrical connection(s) with the copper portion **506a** via solder (not illustrated). The chip **514** includes a bond pad **516**. A wire bonding process results in wires **518** being routed from the bond pad **516** to the copper portions **506b**, **506c**.

FIG. 5E illustrates a molding step that results in a mold **520** that encapsulates and protects the package **500**. The mold **520** can be made of plastic or other suitable material. As can be seen, the mold **520** covers the chip **514** and bond pad **516**, as well as the wires **518**. The mold **520** also fills in among and over the various components, including the copper portions **506a**, **506b**, **506c**.

FIG. 5F illustrates a step of removing the carrier copper foil **502** to complete the package **500**. Removal of the carrier copper foil **502** is facilitated by and results in the removal of the interface release layer **504**. Removal of the carrier copper foil **502** can be achieved by heating the package **500** at a medium temperature to release the interface release layer **504**. The carrier copper foil **502** can then be peeled away from the copper portions **506a**, **506b**, **506c** and the mold **520**.

As previously discussed, sometimes upon removal of a carrier copper foil from conventional packaging, various components similar to, for example, the copper portions **506a**, **506b**, **506c**, are pulled or "popped" out of the mold. However, in embodiments of the present disclosure where conductive tops **508** are included, the conductive tops **508** on the copper portions **506a**, **506b**, **506c** help inhibit removal or "popping" out of the copper portions **506a**, **506b**, **506c**. This is due in part to the width of the conductive tops **508** and the mold **520** encapsulating and "grabbing" the conductive tops **508** in conjunction with the copper portions **506a**, **506b**, **506c**. In accordance with various embodiments not illustrated in the figures, the copper portion **506a** does not include a conductive top **508** since the presence of the chip **514** in combination with the copper portion **506a** inhibits "popping" out of the chip **514** and the corresponding copper portion **506a**.

With respect to FIG. 5G, solder balls **522** are attached to the copper portions **506a**, **506b**, **506c** to facilitate attachment

of the resulting single-layer package **500** to a substrate such as, for example, a printed circuit board (PCB), another package, etc. (not illustrated). If a solder ball **522** does not fully cover a surface of a corresponding copper portion **506a**, **506b**, **506c**, then a mask (not illustrated) may be provided to cover exposed portions of the surface of the corresponding copper portion **506a**, **506b**, **506c** in order to protect the exposed portions of the surface of the corresponding copper portion **506a**, **506b**, **506c**. The solder balls **522** also provide direct electronic connections between the copper portions **506a**, **506b**, **506c** and the substrate (not illustrated).

The package **500** is generally a single layer ball grid array (BGA) package. The package **500** is also referred to as a quad-flat no-leads (QFN) package.

FIG. 6 illustrates an example of a method **600** for creating a package, such as, for example, package **500**. At **602**, an initial substrate is provided. The initial substrate comprises a carrier foil and an interface release layer coupled to the carrier foil. At **604**, copper portions are deposited on the interface release layer. The depositing comprises (i) depositing liquid copper nano particles on the interface release layer in a predetermined pattern and (ii) curing the liquid copper nano particles. At **606**, a chip is attached to a first copper portion. At **608**, the chip is coupled to a second copper portion. At **610**, at least the chip and the copper portions are encapsulated with a mold. At **612**, the carrier foil and interface release layer are removed.

The disclosure described above may be used to build leadframes for multi-row QFN (quad-flat no-leads) or single layer BGA (ball grid array). The leadframe itself is built on a copper layer by etching the pattern that a user desires. A chip would then be mounted onto the leadframe with the carrier foil still attached. Wirebonding or flip chip soldering can be used to provide connections between the chip and the leadframe. Plastic molding or encapsulation is then used to seal the entire package. Subsequently, the carrier foil is peeled off or removed and solder connections may be added as desired.

Various operations may have been described as multiple discrete actions or operations in turn, in a manner that is most helpful in understanding the claimed subject matter. However, the order of description should not be construed as to imply that these operations are necessarily order dependent. In particular, these operations may not be performed in the order of presentation. Operations described may be performed in a different order than the described embodiment. Various additional operations may be performed and/or described operations may be omitted in additional embodiments.

The description may use the terms "embodiment" or "embodiments," which may each refer to one or more of the same or different embodiments. Furthermore, the terms "comprising," "including," "having," and the like, as used with respect to embodiments, are synonymous.

Although certain embodiments have been illustrated and described herein, it will be appreciated by those of ordinary skill in the art that a wide variety of alternate and/or equivalent embodiments or implementations calculated to achieve the same purposes may be substituted for the embodiments illustrated and described without departing from the scope. Those with skill in the art will readily appreciate that embodiments may be implemented in a very wide variety of ways. This application is intended to cover any adaptations or variations of the embodiments discussed

herein. Therefore, it is manifestly intended that embodiments be limited only by the claims and the equivalents thereof.

What is claimed is:

1. A method of creating a package, the method comprising:
 - providing an initial substrate, wherein the initial substrate comprises
 - a first foil,
 - a second foil, and
 - an interface release layer between the first foil and the second foil, wherein the interface release layer is configured to allow subsequent peeling and releasing of the first foil from the second foil;
 - building up a plurality of copper portions on the second foil;
 - attaching a chip to a first copper portion of the plurality of copper portions;
 - coupling the chip to a second copper portion of the plurality of copper portions;
 - encapsulating at least the chip and the plurality of copper portions with a mold; and
 - subsequent to encapsulating at least the chip and the plurality of copper portions with the mold, removing the first foil and interface release layer from the package.
2. The method of claim 1, wherein building up the plurality of copper portions comprises:
 - performing a photolithography operation to create portions of photoresist material;
 - plating copper between the portions of photo resist material; and
 - removing the portions of photoresist material to create the plurality of copper portions.
3. The method of claim 2, wherein removing the portions of photoresist material includes removing portions of the second foil between the plurality of copper portions.
4. The method of claim 3, wherein removing portions of the second foil between the plurality of copper portions includes removing portions of the second foil between the plurality of copper portions such that portions of the second foil below the plurality of copper portions are removed to thereby expose a bottom surface of each copper portion.
5. The method of claim 4, wherein encapsulating at least the chip and the plurality of copper portions with a mold includes encapsulating at least the chip and the plurality of copper portions with the mold such that portions of the mold are located between the second foil and the exposed bottom surfaces of the plurality of copper portions.
6. The method of claim 1, further comprising forming a metal portion on the second copper portion, wherein the metal portion is wider than the second copper portion.
7. A method of creating a package, the method comprising:
 - providing an initial substrate, wherein the initial substrate comprises
 - a first foil,
 - a second foil, and
 - an interface release layer between the first foil and the second foil;
 - building up plurality of copper portions on the second foil;
 - attaching a chip to a first copper portion;

- coupling the chip to a second copper portion;
- encapsulating at least the chip and the plurality of copper portions with a mold; and
- removing the first foil and interface release layer, wherein removing the first foil and interface release layer comprises:
 - heating the package to release the interface release layer from the second foil thereby releasing the first foil.
8. A method of creating a package, the method comprising:
 - providing an initial substrate, wherein the initial substrate comprises
 - a first foil, wherein the first foil comprises a carrier copper foil,
 - a second foil, and
 - an interface release layer between the first foil and the second foil;
 - building up plurality of copper portions on the second foil;
 - attaching a chip to a first copper portion;
 - coupling the chip to a second copper portion;
 - encapsulating at least the chip and the plurality of copper portions with a mold; and
 - removing the first foil and interface release layer.
9. The method of claim 1, wherein the interface release layer comprises chromium.
10. The method of claim 1, wherein coupling the chip to the second copper portion comprises coupling the chip to the second copper portion via a wire bonding process.
11. The method of claim 1, wherein attaching the chip to the first copper portion comprises attaching the chip to the first copper portion via a flip chip attach process.
12. The method of claim 1, wherein attaching the chip to the first copper portion comprises attaching the chip to the first copper portion via an epoxy or glue.
13. The method of claim 1, further comprising attaching solder balls to the second foil under the plurality of copper portions.
14. The method of claim 1, wherein building up plurality of copper portions on the second foil comprises forming the plurality of copper portions such that a first portion of at least the second copper portion is wider than a second portion of the second copper portion, wherein the second portion is adjacent to the second foil.
15. The method of claim 1, wherein the first foil comprises a carrier aluminum foil.
16. The method of claim 1, wherein the second foil comprises a functional copper foil.
17. The method of claim 1, wherein the second foil comprises a functional aluminum foil.
18. The method of claim 1, wherein removing the first foil and interface release layer comprises:
 - peeling the first foil to remove the first foil and the interface release layer from the second foil.
19. The method of claim 1, wherein removing the first foil and interface release layer comprises:
 - heating the interface release layer; and
 - based on heating the interface release layer, peeling the first foil to remove the first foil and the interface release layer from the second foil.